S/N 10/656,745

AUG 1 4 2006

IN THE CONTERNATATES PATENT AND TRADEMARK OFFICE

Applicant:

Robert William Courtenay

Examiner:

Kirsten C. Jolley

Serial No.:

10/656,745

Group Art Unit:

1762

Filed:

September 05, 2003

Docket:

303.936US5

Title:

METHOD AND APPARATUS FOR COATING A WAFER

INFORMATION DISCLOSURE STATEMENT

MS RCE Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

In compliance with the duty imposed by 37 C.F.R. § 1.56, and in accordance with 37 C.F.R. §§ 1.97 et. seq., the enclosed materials are brought to the attention of the Examiner for consideration in connection with the above-identified patent application. Applicant respectfully requests that this Information Disclosure Statement be entered and the documents listed on the attached Form 1449 be considered by the Examiner and made of record. Pursuant to the provisions of MPEP 609, Applicant requests that a copy of the 1449 form, initialed as being considered by the Examiner, be returned to the Applicant with the next official communication.

Pursuant to 37 C.F.R. §1.97(b), it is believed that no fee or statement is required with the Information Disclosure Statement. However, if an Office Action on the merits has been mailed, the Commissioner is hereby authorized to charge the required fees to Deposit Account No. 19-0743 in order to have this Information Disclosure Statement considered.

1.98(a)(2).

Title: METHOD AND APPARATUS FOR COATING A WAFER

Page 2 Dkt: 303.936US5

Pursuant to 37 C.F.R. 1.98(a)(2), Applicant believes that copies of cited U.S. Patents and Published Applications, and Non-Published Applications identifiable by USPTO Serial Number, are no longer required to be provided to the Office. Notification of this change to this effect was provided in the United States Patent and Trademark Office OG Notices dated October 12, 2004 and October 19, 2004. Thus, Applicant has not included copies of any US Patents or US Patent Applications identifiable by serial number that may be cited with this submission. Should the Office require copies to be provided, Applicant respectfully requests that notice of such requirement be directed to Applicant's below-signed representative. Applicant acknowledges the requirement to submit copies of foreign patent documents and non-patent literature in accordance with 37 C.F.R.

The Examiner is invited to contact the Applicant's Representative at the below-listed telephone number if there are any questions regarding this communication.

Respectfully submitted,

ROBERT WILLIAM COURTENAY

By his Representatives,

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Reg. No. 40,957

CERTIFICATE UNDER 37 CFR 1.8: The undersigned hereby certifies that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail, in an envelope addressed to: MS RCE, Commissioner for Patents, P.O. Box 1450, Alexendria, VA 22313-1450 on this ______ day of August 2006.

MATG GALLON

Signature

PTO/SB/08A(10-01)
Approved for use through 10/31/2022, OMB 651-0031
US Patent & Trademerk Office: U.S. DEPARTMENT OF COMMERCE
Under the Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it contains a valid OMB control number.

Substitute for form 1449A/PTO Complete if Known INFORMATION DISCLOSURE 10/656,745 **Application Number** STATEMENT BY APPLICANT September 5, 2003 Filing Date (Use as many sheets as necessary) PE Courtenay, Robert **First Named Inventor** 1762 **Group Art Unit** AUG 1 4 2006 Jolley, Kirsten **Examiner Name** Attorney Docket No: 303.936US5 Sheet 1 of 1

		US PAT	ENT DOCUMENTS	
Examiner Initial *	USP Document Number	Publication Date	Name of Patentee or Applicant of cited Document	Filing Date If Appropriate
	US-3,793,054	02/19/1974	Franz, Helmut	07/06/1971
	US-3,876,450	04/08/1975	Tanner, W J.	08/13/1973
	US-4,340,622	07/20/1982	Kik, Leendert, et al.	11/19/1979
	US-4,806,504	02/21/1989	Cleeves, James M.	09/11/1986
	US-4,822,639	04/18/1989	Fujii, Itsuo, et al.	08/21/1987
	US-5,066,616	11/19/1991	Gordon, William G.	09/07/1990
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-	US-5,270,079	12/14/1993	Bok, Hendrik	12/18/1992
-	US-5,360,995	11/01/1994	Graas, Carole D.	09/14/1993
	US-5,366,757	11/22/1994	Lin, Burn J.	10/30/1992
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FOREIGN PATENT DOCUMENTS						
Examiner Initials*	Foreign Document No	Publication Date	Name of Patentee or Applicant of cited Document	T²		

OTHER DOCUMENTS NON PATENT LITERATURE DOCUMENTS					
Examiner Initials*	Cite No 1	include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T²		

<u>S/N 10/656,745</u> <u>PATENT</u>

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Robert W. Courtenay

Examiner: Kirsten C. Jolley

Serial No.:

10/656,745

Group Art Unit: 1762

Filed:

September 5, 2003

Docket: 303.936US5

Fitle:

METHOD AND APPARATUS FOR COATING A WAFER

COMMUNICATION CONCERNING RELATED APPLICATION(S)

AUG 1 4 2006 MS RVE

chamissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Applicant would like to bring to the Examiner's attention the following related application(s) in the above-identified patent application:

Serial/Patent No. 08/508051	Filing Date/Issue Date July 27, 1995	Attorney Docket 303.936US1	<u>Title</u> METHOD AND APPARATUS FOR IMPROVED COATING OF A SEMICONDUCTOR WAFER
08/949072 5,902,399	October 10, 1997	303.936US2	METHOD AND APPARATUS FOR IMPROVED COATING OF A SEMICONDUCTOR WAFER
09/292081 6,423,380	April 14, 1999	303.936US3	METHOD AND APPARATUS FOR IMPROVED COATING OF A SEMICONDUCTOR WAFER
11/459426	July 24, 2006	303.936US6	METHOD AND APPARATUS FOR COATING A WAFER

Continuations and divisionals may be later filed on the cases listed above, or cited to the Examiner in any previous Communication Concerning Related Applications. Applicants request that the Examiner review all continuations and divisionals of the above-listed or previously-cited patent applications before allowing the claims of the present patent application.

Respectfully submitted,

ROBERT W. COURTENAY

By Applicant's Representatives,

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Timothy B. Clise

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LATE GANNON

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